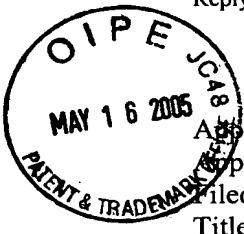


Appl. No. 10/621,497
Amdt. Dated May 12, 2005
Reply to Office action of April 18, 2005



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/621,497
Applicant : Tetsuhiro Iwai et al.
Filed : July 17, 2003
Title : PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

Conf. No. : 2610
TC/A.U. : 1765
Examiner : Lan Vinh

Customer No. : 000,116
Docket No. : 35908

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE "B" AND ELECTION

Sir:

This communication is filed in response to the Office action dated April 18, 2005 (Paper No. 041205). The one month period for responding to the Office action expires on May 18, 2005.

Remarks begin on page 2 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Michael W. Garvey
Name of Attorney for Applicant(s)

May 12, 2005

Signature of Attorney/Date